



PATENT
Customer No. 22,852
Attorney Docket No. 07553.0030 (formerly 07363.0010)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of:)

U.S. Patent No.: 5,792,261)

Inventor: Kiichi HAMA et al.)

Issued: August 11, 1998)

Serial No.: 09/478,370)

Filed: February 16, 2000)

For: PLASMA PROCESS
APPARATUS)

Group Art Unit: 1763

Examiner: L. Alejandro Mulero

#26F
5/27/03
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Commissioner for Patents
Washington, DC 20231

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MAY 27 2003

GROUP 1700

Sir:

AMENDMENT

In response to the Office Action dated December 31, 2002, the period for response having been extended through May 31, 2003, by the attached petition and requisite fee, please amend the application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

37. (Twice Amended) An apparatus for processing with a plasma a process
region of a substrate, comprising:
a container;

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